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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Masahito OZAWA et al.

International PCT Application No.: PCT/JP99/01766

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US Serial No.: 09/647,659

Group Art Unit: 2812

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Examiner: To Be Assigned

For : ALIGNMENT PROCESSING MECHANISM AND SEMICONDUCTOR
PROCESSING UNIT WITH ALIGNMENT PROCESSING MECHANISM

SECOND INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

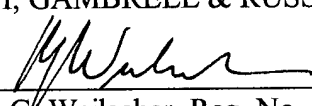
Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists the document cited in the PTO 1449.

It is respectfully requested that each cited document be considered by the Examiner in the above-identified patent application and that each cited document be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,

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